§2. Deuterium Retention in Iron Oxide (Fe₂O₃) under Low-Energy Deuterium Exposure

Matsunami, N., Sogawa, T., Sakuma, Y. (Nagoya Univ. EcoTopia), Ohno, N. (Nagoya Univ. Engineering), Masuzaki, S., Tokitani, M., Ashikawa, N., Sagara, A., Nishimura, K.

Stainless steel (SUS) is widely employed for the nuclear fusion devices. When O_2 -plasma-discharge is performed to remove tritium [1], layers of iron-oxide such as Fe₂O₃ will be formed on SUS surface [2]. Thus, deuterium (D) retention in the oxide layers is important for designing the devices. In this work, we have studied D-retention in Fe₂O₃ under D₂ plasma exposure [3], as well as in SUS and Fe for comparison.

Fe₂O₃ layers were prepared by oxidation of Fe deposited on SiO₂-glass substrates and Fe sheet in air. According to X-ray diffraction (XRD), the oxide layers on SiO₂ oxidized at 400 to 500 °C for more than 5 min are polycrystalline hematite (hexagonal α -Fe₂O₃) while those on Fe oxidized at 500 °C are mixture of α-Fe₂O₃ and cubic γ -Fe₂O₃ (maghemite). Oxide-layer thickness is evaluated by means of Rutherford backscattering spectroscopy (RBS) of 1.8 MeV He⁺ and H⁺, using the stopping power [4] and density of 3.96x10²² Fe cm⁻³ (5.25 g cm⁻³). For analysis of ion beam data, e.g., RBS, SUS is assumed to consist of Fe only with the density of Fe $(8.48 \times 10^{22} \text{ cm}^{-3} \text{ or } 7.86 \text{ g cm}^{-3})$. The samples were exposed to D₂-plasma under AC discharge of 1.5 kV in D₂ gas pressure of 0.4 Torr for 15 min at room temperature [3]. The amount of D was analyzed by using nuclear reaction analysis (NRA), $D(^{3}He,\alpha)H$ with ³He-energy of 1.0 MeV. The NRA cross section was taken after [5]. The depth resolution of the NRA at very near surface is estimated to be ~0.24 and 0.19 µm for Fe₂O₃ and Fe. Also, the probing depth is roughly estimated to be 1.3 and 1µm for Fe₂O₃ and Fe, based on the calculated path length [4] where the ³He beam slows down to 0.25 MeV so that the NRA cross section is reduced to one-fifth of the maximum value.

The results are summarized in Table 1. Firstly, D-retention in α -Fe₂O₃ appears to be independent of the oxide layer thickness of 0.06 to 0.86 µm, indicating low diffusivity of D in α -Fe₂O₃ (<4x10¹⁴ cm²s⁻¹). Secondly, D-retention in γ -Fe₂O₃ is found to be larger by a factor of at least 1.7 than that in α -Fe₂O₃. An explanation is that in γ -Fe₂O₃, non-negligible fraction of vacancies exists in Fe site (defect-spinel-type-structure, e.g., Fe_{2/3}Fe₂O₄ or one third of vacancies at Mg site in the spinel to keep Fe₂O₃ composition) [6]. Therefore it is suggested that D's occupy the vacancy sites in γ -Fe₂O₃, enhancing D-retention. Another explanation is that the D-diffusivity in γ -Fe₂O₃ is larger than that in α -Fe₂O₃, giving rise to larger D-retention. Measurement of D-depth-distribution, estimation of the ratio of γ - to α -Fe₂O₃ in these mixed layers, and preparation of only γ -Fe₂O₃ layers followed by D-retention measurement would be fruitful. In this study, the density of γ -Fe₂O₃ is assumed to be the same as that of α -Fe₂O₃. Due to the presence of vacancies as described above, the density of γ -Fe₂O₃ is smaller by several % than that of α -Fe₂O₃, which is insignificant in the D-retention evaluation.

D-retention in Fe appears to be the smallest in this study and a half of that in α -Fe₂O₃, in spite of a large diffusivity of H and D in Fe [7]. Surprisingly, D-retention in SUS is larger than that in Fe and α -Fe₂O₃. The amount of oxygen near surface of Fe and SUS is obtained to be ~13x10¹⁶ cm⁻², by using ¹⁶O(d, α)¹⁴N with 1.2 MeV d. This indicates the existence of oxide layers near surface and a contribution of the oxide layers to D-retention.

Table 1 Summary of D-retention in Fe_2O_3 , Fe and SUS (an estimated error of 15 %). Thickness of oxide layers, Fe and SUS are given in the parenthesis.

Sample	D-retention $(10^{15} \text{ cm}^{-2})$
α-Fe ₂ O ₃ /SiO ₂ (0.06, 0.18, 0.86 μm)	21
(α+γ)-Fe ₂ O ₃ /Fe (>2μm)	36
Fe (0.2 mm)	12
SUS (0.25, 2 mm)	27

- 1. R. E. H. Clark, D. H. Reiter, eds. Nuclear Fusion Research, Springer, 2004.
- C. Anandan, K.S. Rajam, Appl. Surf. Sci. 253(2007) 6854.
- T. Sogawa, N. Matsunami, N. Ohno, M. Tokitani, S. Masuzaki, CP1231 Ion Implantation technology 2010, eds. J. Matsuo et. Al., AIP 2010 and Int. Conf. PFMC-13/FEMS-1, Germany, 2011.
- J.F. Ziegler, J.P. Biersack, U. Littmark, The Stopping and Range of Ions in Solids, Pergamon Press, New York, 1985.
- 5. W. Moller, F. Besenbacher, Nucl. Instrum. Meth. 168(1980)111.
- M. Lie, H. Fjellvag, A. Kjekshus, Thin Solid Films 488(2005)74.
- H. Hagi, Y. Hayashi, Trans. Japan Institute Metals 28 (1987)368.